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CONFIRMATION NO. 2896

Bib Data Sheet							_
SERIAL NUMBER 09/767,659	FILING DATE 01/22/2001 RULE	C	CLASS 414	GROUP ART 3652	UNIT	D ₁	ATTORNEY OCKET NO. 736-1/AJT/MSS
APPLICANTS							
Richard N. Savage, Scotts Valley, CA;							
Frank S. Menagh, Santa Cruz, CA; Helder R. Carvalheria, Scotts Valley, CA;Philip A. Troiani, Santa Cruz, CA; Dan L. Cossentine, Santa Cruz, CA; Eric R. Vaughan, Santa Cruz, CA; Bruce E. Mayer, Soquel, CA;							
** CONTINUING DATA **********************************							
** FOREIGN APPLICATIONS ************************************							
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 04/23/2001							
Foreign Priority claimed 35 USC 119 (a-d) conditions	yes no Met after Allowance Initials	ter	STATE OR	SHEETS	тот	AL	INDEPENDENT
met Verified and Acknowledged Exc			COUNTRY CA	DRAWING 16	CLAI 6		CLAIMS 2
ADDRESS Maria S. Swiatek FLEHR HOHBACH TEST ALBRITTON & HERBERT LLP Four Embarcadero Center, Suite 3400 San Francisco, CA 94111-4187							
TITLE Semiconductor wafer transfer system	processing system with	ı verticall	y-stacked prod	cess chambers	and sin	gle-ax	is dual-wafer
☐ All Fees							



United States Patent and Trademark Office

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandra, Viginia 22313-1450 www.uspto.gov

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ADDRESS Maria S. Swiatek FLEHR HOHBACH TEST ALBRITTON & HERBERT LLP Four Embarcadero Center, Suite 3400 San Francisco, CA 94111-4187								
TITLE Semiconductor wafe ransfer system	er processing system with	vertically-stacked proc	ess chambers	and single	-axis dual-wafer			
	☐ All Fees							
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SERIAL NUMBER 09/767,659	FILING DATE 01/22/2001 RULE	CLASS 438 <i>41 4</i>	GROUP ART UNIT		ATTORNEY DOCKET NO. A-67736-	
APPLICANTS		1.			1/AJT/MSS	
Richard N. Sa Frank S. Men Helder R. Ca Philip A. Troia Dan L. Cosse Eric R. Vaugh	avage, Scotts Valley, CA lagh, Santa Cruz, CA; rvalheria, Scotts Valley, e ani, Santa Cruz, CA; ntine, Santa Cruz, CA; nan, Santa Cruz, CA; er, Soquel, CA;			-	,	
AND CLAIMS	ATION IS A DIV OF 09/ BENEFIT OF 60/127,53 BENEFIT OF 60/127,65	32 04/02/1999				
GRANTED ** 04/23/	C3 351		•		÷	
Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged Ex	yes no Met after Allowance Min Met after Min Min Min Met after Min	2 CA	SHEETS DRAWING 16	TOTAL CLAIMS 6	INDEPENDENT CLAIMS 2	
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San Francisco ,CA 9	4111-4187					
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